



PATENT
Customer No. 22,852
Attorney Docket No. 04329.2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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Yoshio Ozawa et al.

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Group Art Unit: 2823

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Application No.: 09/559,757

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Examiner: Pham, Thanh V.

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Filed: April 27, 2000

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Confirmation No. 2923

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For: METHOD OF MANUFACTURING
A SEMICONDUCTOR DEVICE
USING AN OXIDATION PROCESS

)

)

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Final Office Action mailed January 11, 2005, the period for response to which extends through May 11, 2005, by the Petition for Extension of Time of One (1) Month and requisite fee payment, and concurrent with the Request for Continued Examination (RCE) filed herewith, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 7 of this paper.